

PATENT ASSIGNMENT COVER SHEET

Electronic Version v1.1
 Stylesheet Version v1.2

EPAS ID: PAT6604755

SUBMISSION TYPE:	NEW ASSIGNMENT	
NATURE OF CONVEYANCE:	ASSIGNMENT	
CONVEYING PARTY DATA		
	Name	Execution Date
	ETRON TECHNOLOGY, INC.	03/15/2021
RECEIVING PARTY DATA		
Name:	Etron Technology, Inc.	
Street Address:	No. 6, Technology Road 5	
City:	Hsinchu	
State/Country:	TAIWAN	
Name:	Invention And Collaboration Laboratory Pte. Ltd.	
Street Address:	160 Robinson Rd., #23-02	
City:	Singapore	
State/Country:	SINGAPORE	
PROPERTY NUMBERS Total: 1		
	Property Type	Number
	Application Number:	16395257
CORRESPONDENCE DATA		
Fax Number:		
<i>Correspondence will be sent to the e-mail address first; if that is unsuccessful, it will be sent using a fax number, if provided; if that is unsuccessful, it will be sent via US Mail.</i>		
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ATTORNEY DOCKET NUMBER:	ETRP0333USA	
NAME OF SUBMITTER:	SIBYL YU	
SIGNATURE:	/SIBYL YU/	
DATE SIGNED:	03/16/2021	
Total Attachments: 4		
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source=4150075#page2.tif		
source=4150075#page3.tif		

Form of Recordable Patent Assignment and Reservation

WHEREAS, in consideration of One Dollar(\$1.00) and other goods and valuable considerations, the receipt of which is hereby acknowledged, and subject to the reservations stated in the Patent Assignment Agreement

Etron Technology, Inc., a corporation organized and existing under the laws of
TAIWAN,

(hereinafter "ASSIGNOR(S)")

HEREBY grant(s) and assign(s) to

Etron Technology, Inc., a corporation organized and existing under the laws of
TAIWAN,

Invention And Collaboration Laboratory Pte. Ltd., a corporation organized and
existing under the laws of SINGAPORE,

(hereinafter "ASSIGNEE(S)")

all of the ASSIGNOR(S)'s rights, title and interest in and to the United States Letters Patent(s) and patent application(s) identified in Exhibit A attached hereto, (hereinafter, collectively, "ASSIGNED PATENT(S)"), to have and to hold the same, unto ASSIGNEE(S) for his/their own use and enjoyment and for the use and enjoyment of his/their successors and assigns, including all damages for infringement of any of the ASSIGNED PATENT(S) and the sole right to sue therefore under such ASSIGNED PATENT(S), for the full term(s) of all such ASSIGNED PATENT(S), subject to all rights granted under the ASSIGNED PATENT(S) to third parties by ASSIGNOR(S) prior to the effective date of the said Patent Assignment Agreement.

ASSIGNOR(S) hereby reserve(s) and retain(s), for the benefit of himself/themselves and his/their subsidiaries and their successors and assigns, the rights and licenses set forth in the Patent Assignment

Etron Technology, Inc. (Assignor)

Etron Technology, Inc. (Assignee)

Signature: Chao-Chun Lu

Signature: Chao-Chun Lu

Name: Chao-Chun Lu

Name: Chao-Chun Lu


Title: CEO and Chairman

Title: CEO and Chairman

Date: MAR 15 2021

Date: MAR 15 2021

Invention And Collaboration Laboratory
Pte. Ltd. (Assignee)

Signature: _____

Name: Tzu-Chin Yao

Title: Chairman

Date: MAR 15 2021

Patent Assignment

Exhibit A**United States Patent Application(s)**

Serial No.	Application No.	Filing Date	Assignor		Assignee	
			Name	Interest(%)	Name	Interest(%)
1	62/771,178	2018/11/26	Etron Technology, Inc.	100%	Etron Technology, Inc.	49%
					Invention And Collaboration Laboratory Pte. Ltd.	51%
2	62/771,177	2018/11/26	Etron Technology, Inc.	100%	Etron Technology, Inc.	49%
					Invention And Collaboration Laboratory Pte. Ltd.	51%
3	62/777,727	2018/12/10	Etron Technology, Inc.	100%	Etron Technology, Inc.	49%
					Invention And Collaboration Laboratory Pte. Ltd.	51%
4	62/777,254	2018/12/10	Etron Technology, Inc.	100%	Etron Technology, Inc.	49%
					Invention And Collaboration Laboratory Pte. Ltd.	51%
5	62/783,203	2018/12/21	Etron Technology, Inc.	100%	Etron Technology, Inc.	49%
					Invention And Collaboration Laboratory Pte. Ltd.	51%
6	16/354,187	2019/03/15	Etron Technology, Inc.	100%	Etron Technology, Inc.	49%
					Invention And Collaboration Laboratory Pte. Ltd.	51%
7	62/818,753	2019/03/15	Etron Technology, Inc.	100%	Etron Technology, Inc.	49%
					Invention And Collaboration Laboratory Pte. Ltd.	51%
8	62/824,315	2019/03/27	Etron Technology, Inc.	100%	Etron Technology, Inc.	49%
					Invention And Collaboration Laboratory Pte. Ltd.	51%
9	16/388,836	2019/04/18	Etron Technology, Inc.	100%	Etron Technology, Inc.	49%
					Invention And Collaboration Laboratory Pte. Ltd.	51%
10	16/395,257	2019/04/26	Etron Technology, Inc.	100%	Etron Technology, Inc.	49%
					Invention And Collaboration Laboratory Pte. Ltd.	51%

Form of Recordable Patent Assignment and Reservation

11	62/848,553	2019/05/15	Etron Technology, Inc.	100%	Etron Technology, Inc.	49%
					Invention And Collaboration Laboratory Pte. Ltd.	51%

End of Exhibit A